

## CLAIMS

1. (Amended) A semiconductor storing device in  
which a row of memory cells is selected by a word line stage  
5 and a division word line stage, comprising:

memory arrays that each include a plurality of  
memory cells arranged in a matrix;

word lines for respective rows of the memory cells;

division word lines each of which is connected to  
10 the memory cells arranged in one row corresponding to one  
word;

division word line selectors that select the  
division word lines, respectively, the division word lines  
being connected to the respective word lines via the division  
15 word line selectors, respectively;

pairs of bit lines for reading data from the memory  
cells and writing data to the memory cells that are connected  
to the pairs of the bit lines, respectively;

column gates connected to the pairs of bit lines,  
20 respectively;

pairs of data lines that are connected to the pairs  
of bit lines via the column gates, respectively, to  
communicate data;

write buffers for data writing that are connected  
25 to the pairs of data lines, respectively;

sense operational amplifiers for data reading that are connected to the pairs of data lines, respectively; and

data input/output circuits that are connected to the pairs of data lines via the write buffers and the sense  
5 operational amplifiers, respectively,

wherein input address data is specified by address data  $X[i:0]$ ,  $Y[j:0]$ , and  $Z[k:0]$ , two roots of selection signals for selecting the division word line selectors are provided alternately to the division word lines arranged in  
10 one of the memory arrays, and one of the two roots of the selection signals is enabled to select one of the division word line selectors in the one of the memory arrays,

the semiconductor storing device further comprises a decoder that receives the input address data  $X[i:0]$ ,  $Y[j:0]$ ,  
15 and  $Z[k:0]$ , and causes two or four of the word lines provided in the respective rows of the memory cells to rise simultaneously, and

the semiconductor storing device has an address arrangement that enables eight addresses to be accessed  
20 simultaneously, the eight addresses being represented by  $(z, y, x)$ ,  $(z, y, x+1)$ ,  $(z, y+1, x)$ ,  $(z, y+1, x+1)$ ,  $(z+1, y, x)$ ,  $(z+1, y, x+1)$ ,  $(z+1, y+1, x)$ , and  $(z+1, y+1, x+1)$  when  $(z, y, x)$  is specified by the input address data  $X[i:0]$ ,  $Y[j:0]$ , and  $Z[k:0]$ .

claim 1, further comprising

selectors that are provided between the write  
buffers and the data input/output circuits, and between the  
sense operational amplifiers and the data input/output

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circuits, respectively such that the data input/output  
circuits always correspond one-to-one to the eight addresses  
of (z, y, x), (z, y, x+1), (z, y+1, x), (z, y+1, x+1), (z+1, y,  
x), (z+1, y, x+1), (z+1, y+1, x), and (z+1, y+1, x+1),  
5 respectively, and always transmit and receive, via the  
selectors, respective input data and output data corresponding  
one-to-one to the eight addresses, respectively.

3. The semiconductor storing device according to  
10 claim 1, wherein when at least one of z, y, and x of the  
address (z, y, x) is an allowable maximum value, at least one  
of z+1, y+1, and x+1 that corresponds to the at least one of x,  
y, and z having the allowable maximum value is converted to  
"0" to access the eight addresses simultaneously.

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4. The semiconductor storing device according to  
claim 1, further comprising selection means for selecting  
either a first mode in which the eight addresses are accessed  
simultaneously, or a second mode in which a single address is  
20 accessed.

5. (Amended) A semiconductor storing device in  
which a row of memory cells is selected by a word line stage  
and a division word line stage, comprising:

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memory arrays that each include a plurality of

memory cells arranged in a matrix;

word lines for respective rows of the memory cells;

division word lines each of which is connected to  
the memory cells arranged in one row corresponding to one

5 word;

division word line selectors that select the  
division word lines, respectively, the division word lines  
being connected to the respective word lines via the division  
word line selectors, respectively;

10 pairs of bit lines for reading data from the memory  
cells and writing data to the memory cells that are connected  
to the pairs of the bit lines, respectively;

column gates connected to the pairs of bit lines,  
respectively;

15 pairs of data lines that are connected to the pairs  
of bit lines via the column gates, respectively, to  
communicate data;

write buffers for data writing that are connected  
to the pairs of data lines, respectively;

20 sense operational amplifiers for data reading that  
are connected to the pairs of data lines, respectively; and

data input/output circuits that are connected to  
the pairs of data lines via the write buffers and the sense  
operational amplifiers, respectively,

25 wherein input address data is specified by address

data  $X[i:0]$ ,  $Y[j:0]$ , and  $Z[k:0]$ , four roots of selection signals for selecting the division word line selectors are provided to the division word lines arranged in one of the memory arrays, and one of the four roots of the selection  
5 signals is enabled to select one of the division word line selectors in the one of the memory arrays, and

the semiconductor storing device further comprises a decoder that receives the input address data  $X[i:0]$ ,  $Y[j:0]$ , and  $Z[k:0]$ , and causes one, two or four of the word lines  
10 provided in the respective rows of the memory cells to rise simultaneously, and

the semiconductor storing device has an address arrangement that enables eight addresses to be accessed simultaneously, the eight addresses being represented by  $(z, y, x)$ ,  $(z, y, x+1)$ ,  $(z, y+1, x)$ ,  $(z, y+1, x+1)$ ,  $(z+1, y, x)$ ,  $(z+1, y, x+1)$ ,  $(z+1, y+1, x)$ , and  $(z+1, y+1, x+1)$  when  $(z, y, x)$  is  
15 specified by the input address data  $X[i:0]$ ,  $Y[j:0]$ , and  $Z[k:0]$ .

6. The semiconductor storing device according to  
20 claim 5, further comprising

selectors that are provided between the write buffers and the data input/output circuits, and between the sense operational amplifiers and the data input/output circuits, respectively such that the data input/output  
25 circuits always correspond one-to-one to the eight addresses

of  $(z, y, x)$ ,  $(z, y, x+1)$ ,  $(z, y+1, x)$ ,  $(z, y+1, x+1)$ ,  $(z+1, y, x)$ ,  $(z+1, y, x+1)$ ,  $(z+1, y+1, x)$ , and  $(z+1, y+1, x+1)$ , respectively, and always transmit and receive, via the selectors, respective input data and output data corresponding

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one-to-one to the eight addresses, respectively.

7. The semiconductor storing device according to claim 5, wherein in a case where when the address (z, y, x) is specified, an address determined by at least one of z+1, y+1, and x+1 does not exist in the semiconductor storing device, the at least one of z+1, y+1, and x+1 is converted to "0" to access the eight addresses simultaneously

8. The semiconductor storing device according to claim 5, further comprising selection means for selecting either a first mode in which the eight addresses are accessed simultaneously, or a second mode in which a single address is accessed.

9. (Cancelled)

10. (Cancelled)

11. (Cancelled)

12. (Cancelled)